OK TO ENTER: /C.C./ (05/10/2011)

DOCKET NO: 287800US26PCT

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

MASAYUKI OIKAWA, ET AL. : EXAMINER: CHAN, CEDRIC A.

SERIAL NO: 10/574,286

FILED: MARCH 31, 2006 : GROUP ART UNIT: 1773

FOR: INSPECTION METHOD AND INSPECTION ASSISTING DEVICE FOR QUARTZ PRODUCT OF SEMICONDUCTOR PROCESSING

APPARATUS

## AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated March 31, 2011, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.